CONTENTS

Verner V. D., Maltsev P. P., Saurov A. N. *MEMS and the Third Industrial Revolution*.....2 Based on content analysis of a number of international conferences held in early 2012, shows a decisive role in the development of MEMS third industrial revolution.

Keywords: microelectromechanical systems, wireless sensors, global project, internet of things, monitoring, industrial revolution

Keywords: carbon tubes, porous aluminum oxide, nanosized structures, electrochemical processes

Keywords: terahertz technology, quantum cascade laser, quasiperiodic structure, Fibonacci sequence, Thue–Morse sequence, superlattice

Keywords: nanoionics, nanoionic devices, solid electrolytes, advanced superionic conductors, blocking heterojunctions, fast ion transport, computer modeling, hidden and observable variables, detailed balance, kinetic equation

Keywords: amorphous nuclear structure, systems of the iterated functions, radial functions of distribution

The results of the laser obtaining of semiconductor nanoparticles by continuous laser irradiation of near-IR range (up to 10^6 W/cm^2) on a massive sample PbX in the liquid are demonstrated. The placing of PbX quantum dots on a substrate was made by the method of droplet deposition. Using a simulation model the formation's features of deposited layers in the process of evaporation were described. **Keywords:** semiconductor particles, colloidal solution, the Monte-Carlo method

Keywords: gyrovertical, micromechanical sensitive elements, Allan variance

Keywords: multilayer antenna, multilayer printed antenna, aperture coupled antenna, phased array, dual-frequency, circular or elliptical polarized antenna radiation

- the instability of electrical current arise after saturation in high electrical fields if the current is measured across the nanothreads.

Keywords: nanostructures, quantum wires, quantum threads, molecular beam epitaxy

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